

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MIKI OGAWA) : Examiner: Nathan H. Empie
Appln. No.: 10/521,242) : Art Unit: 1792
Filed: January 14, 2005) : Confirmation No.: 7202
For: MESOSTRUCTURED FILM, POROUS)
FILM AND THE METHOD OF PREPARING :
THE SAME) : July 10, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

(a) Introductory Comments

In response to the restriction requirement dated June 11, 2008, kindly consider the remarks which follow.